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Attorney's Docket No. 042390.P5778D  
Express Mail No. EM014067311US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

**Krishna Seshan; M. Lawrence A. Dass; and Geoffrey L. Bakker**

Serial No.

Filed: November 6, 2001

**For: Semiconductor Passivation Deposition Process for  
Interfacial Adhesion (Amended)**

### Divisional Application of:

Divisional Application  
Serial No. 09/105,590

Serial No. 69,163,593  
Filed: June 26, 1998

Examiner: Brophy, J.

## Art Unit 2822



## **INFORMATION DISCLOSURE STATEMENT**

In accordance with 37 C.F.R. § 1.56, Applicants hereby disclose the prior art references that have been submitted and/or cited in related application, as follows:

U.S. Serial No. 09/105,590, filed June 26, 1998.

A copy of form PTO-892 filed in the related application is enclosed. Copies of the references are not provided as permitted by 37 C.F.R. § 1.98(d).

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN, LLP

Date: 11/6/01

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